

**Search Notes**

Application/Control No.

10/803,587

Examiner

Tan V. Mai

Applicant(s)/Patent under  
Reexamination

UMENO, KEN

Art Unit

2193

**SEARCHED**

| Class   | Subclass | Date       | Examiner |
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| updated | search   | 11/12/2007 | MAI      |
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**INTERFERENCE SEARCHED**

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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

|  | DATE       | EXMR |
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| updated search (see search history<br>printout(s)) | 11/12/2007 | MAI  |
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